



IFW / AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Sarah E. Kim et al.

Serial No.: 10/669,212

Filed: September 24, 2003

For: Packaged Electroosmotic Pumps  
Using Porous Frits for Cooling  
Integrated Circuits

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Art Unit: 2815

Examiner: Chris C. Chu

Atty Docket: ITL.1039US  
P14622

Assignee: Intel Corporation

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY TO FINAL REJECTION**

Sir:

In response to the final rejection mailed August 9, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: August 24, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Cynthia L. Hayden*  
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